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## BIB DATA SHEET

CONFIRMATION NO. 3390

SERIAL NUMBER	FILING or 371(c) DATE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.
09/885,451	06/20/2001	205	1795	291958170US02
RULE				
<b>APPLICANTS</b> Thomas L. Ritzdorf, Bigfork, MT; E. Henry Stevens, Colorado Springs, CO; Linlin Chen, Kalispell, MT; Lyndon W. Graham, Kalispell, MT; Curt Dundas, Kalispell, MT;				
<b>** CONTINUING DATA *****</b> This application is a CON of 09/387,577 08/31/1999 PAT 6,508,920 which is a CON of PCT/US99/02504 02/04/1999 which is a CON of 09/018,783 02/04/1998 PAT 7,244,677 and claims benefit of 60/087,432 06/01/1998				
<b>** FOREIGN APPLICATIONS *****</b>				
<b>** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **</b> 08/10/2001				
Foreign Priority claimed <input type="checkbox"/> Yes <input checked="" type="checkbox"/> No 35 USC 119(a-d) conditions met <input type="checkbox"/> Yes <input checked="" type="checkbox"/> No Verified and Acknowledged <u>/WILLIAM T. LEADER/</u> Examiner's Signature	<input type="checkbox"/> Met after Allowance Initials	<b>STATE OR COUNTRY</b> MT	<b>SHEETS DRAWINGS</b> 7	<b>TOTAL CLAIMS</b> 39
<b>INDEPENDENT CLAIMS</b> 7				
<b>ADDRESS</b> PERKINS COIE LLP P.O. BOX 1247 PATENT-SEA SEATTLE, WA 98111-1247 UNITED STATES				
<b>TITLE</b> Method for low temperature annealing of metallization micro-structures in the production of a microelectronic device				
<b>FILING FEE RECEIVED</b> 2398	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	